Receipt date: 07/03/2008

Doc code :IDS

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10689781 - GAU: 2624 PTO/SB/08a (03-08)

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Application Number 10689781 Filing Date 2003-10-22 INFORMATION DISCLOSURE First Named Inventor Mitsuru Owada STATEMENT BY APPLICANT Art Unit 2624 (Not for submission under 37 CFR 1.99) R. Chu **Examiner Name** Attorney Docket Number 00862.023275.

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	1	2000-023197	JP				Omi et al.				
	2	2002-094804	JP				Sato				
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